

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

priority Application Serial No. 09/633,556
priority Filing Date August 7, 2000
Inventor Gurtej S. Sandhu et al.
Assignee Micron Technology, Inc.
priority Group Art Unit 2813
priority Examiner Laura M. Schillinger
Attorney's Docket No. MI22-1897
Title: Methods of Forming Transistors (As Amended)

PRELIMINARY AMENDMENT

To: Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

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In the Specification

Replace the title with --Methods of Forming Transistors--.

At page 1, before the "Technical Field" section, please insert:

--CROSS REFERENCE TO RELATED APPLICATION

This patent resulted from a divisional application of U.S. Patent

Application Serial No. 09/633,556, which was filed on August 7, 2000. -- Now U.S. Pat. No. 6,660,657

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